

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of
Itsuki KAJINO et al.

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For: SUBSTRATE PROCESSING APPARATUS

VIA EFS-WEB

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

SUBMISSION

Sir:

Submitted herewith is a copy of art together with a form listing the same for the convenience of the Examiner.

I certify that each item of information contained in this Submission was cited in a communication from a foreign patent office in a counterpart foreign application not more than 3 months prior to the filing of this Submission. Please note that Japanese reference 2000-084503 and the Japanese references 2002-059067, 11-087294 with English abstracts have been previously submitted on June 22, 2004, English translations are currently being submitted.

In the event the actual fee is greater than the payment submitted or is inadvertently not enclosed or if any additional fee due during the pendency of this application is not paid, the patent and Trademark Office is authorized to charge the underpayment to Deposit Account No. 15-0700.

Respectfully submitted,

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